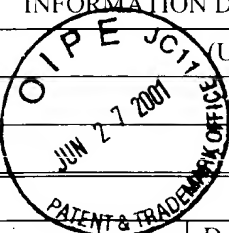


U.S. Department of Commerce, Patent and Trademark Office				Atty Docket No. M-8555 US		Serial No. 09/578,798		
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use several sheets if necessary)				Applicant Jaime Poris				
				Filing Date May 23, 2000		Group Unknown 2873		
U.S. Patent Documents								
*Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate		
	AA					/		
	AB							
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	AH							
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	AJ							
	AK							
Foreign Patent Documents								
		Document	Date	Country	Class	Subclass	Translation Yes No	
	AL						/	
	AM							
	AN							
	AO							
	AP							
OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)								
W.C.	AQ	Makosch, G., "LASSI - a scanning differential ac interferometer for surface profile and roughness measurement" <i>SPIE Vol. 1009</i> (1988); Pages 244-253.						
	AR	/						
	AS							
Examiner W.C.		Date Considered 7/25/02						
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.								